Electronic Patent Application Fee Transmittal							
Application Number:	10539245						
Filing Date:	29-Mar-2006						
Title of Invention:	SUBSTRATE HOLDING MECHANISM, SUBSTRATE POLISHING APPARATUS AND SUBSTRATE POLISHING METHOD						
First Named Inventor/Applicant Name:	Tetsuji Togawa						
Filer:	Nils Erik .Pedersen/Karen Gass						
Attorney Docket Number:	2005-0993A						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
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Claims:							
Miscellaneous-Filing:							
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Utility Appl issue fee		1501	1	1440	1440		
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